



AF/ICJ

Docket No.: 204552030200
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Tetsuyoshi INOUE

Application No.: 10/679,497

Confirmation No.: 8843

Filed: October 7, 2003

Art Unit: 2828

For: SEMICONDUCTOR LASER DEVICE

Examiner: Ernest Unelus

RESPONSE UNDER 37 CFR 1.116(b)

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 13, 2006, the following remarks and request for reconsideration are respectfully submitted.

Remarks/Arguments begin on page 2 of this paper.

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